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AP3 Rec'd PCT/PTO 21 JUN 2006

033082M331

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Toshihisa Nozawa, et al.

International Application No.: PCT/JP2004/019406

International Filing Date: December 24, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: TEMPERATURE REGULATING METHOD FOR SUBSTRATE TREATING
SYSTEM AND SUBSTRATE TREATING SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

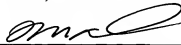
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the International Search Report (ISR) filed herewith. According to the search report, U.S. Patent No. 6,148,626 is a family member of JP 11-183005. Copies of the non-U.S. cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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June 21, 2006

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FORM PTO-1449	ATTY. DOCKET 033082M331	SERIAL NO. To Be Assigned
INFORMATION DISCLOSURE STATEMENT	APPLICANT: Toshihisa Nozawa, et al.	
10/583847	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
/CJ/	AA	6,148,626	11/21/00	Iwamoto			
	AB						
	AC						
	AD						
	AC						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
/CJ/	AH	11-183005	7/6/99	Japan			Abstract
	AI	2000-284832	10/13/00	Japan			Abstract
	AJ	05-163096	6/29/93	Japan			Abstract
↓	AK	05-029261	2/5/93	Japan			Abstract
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER: /Chen Wen Jiang/ (09/13/2010)	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.